

Attorney's Docket No.: 12732-008001 / US4579

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shunpei YAMAZAKI et al.

Art Unit : 2813

Serial No.: 09/769,765

Examiner: Laura Schillinger

Filed

: January 26, 2001

Title

: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants submit the references listed on the attached form PTO-1449.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

FEB 2 0 2004

Date: February 13, 2004

John F. Hayden Reg. No. 37,640

Customer No. 26171

Fish & Richardson P.C. 1425 K Street, N.W., 11th Floor Washington, DC 20005-3500

Telephone: (202) 783-5070 Facsimile: (202) 783-2331

40203753.doc

FEB 1 3 2004 A

Substitute Form PTO-1449 (Modified)

U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. 12732-008001

Application No. 09/769,765

Information Disclosure Statement by Applicant (Use several sheets if necessary) Applicant Shunpei YAMAZAKI et al.

Filing Date

Group Art Unit 2813

(37 CFR §1.98(b))

January 26, 2001

			U.S. Patent	Documents			
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001/0025959 A1	10/04/2001	Yamazaki et al.			02/21/2001
	AB	2001/0030322 A1	10/18/2001	Yamazaki et al.			02/02/2001
	AC	2002/0158288 A1	10/31/2002	Yamazaki et al.			02/21/2002
	AD						
	AE						
	AF				FFR O	0 2004	
	AG				1696	y 	
	AH						
	ΑI						
	AJ						
- "	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or			Trans	slation
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO					-		
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)					
Examiner Initial	Desig. ID	Document			
	AQ				
	AR				
	AS				
	AT				

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if no	ot in conformance and not considered. Include copy of this form with

next communication to applicant.